M. Tech. in Electronics & Communication Engineering – VLSI (ECE-VLSI)

Curricular Structure

M.Tech. - ECE (Microelectronics & VLSI Design)

<u>First Year, First Semester</u>

	A. Theor	y					
SI.	Course	Course Name	Cor	ntact]	Hours	s/Week	Credit
No.	Code		L	Т	Р	Total	Points
1	MATH5103	Advanced Mathematics400				4	4
2	VLSI5101	VLSI Device & Modelling 4 0 0				4	4
3	VLSI5102	Digital IC Design	4	0	0	4	4
4	VLSI5103	Microelectronic Technology & IC Fabrication	4	0	0	4	4
5		Elective – I					
	VLSI5131	Embedded Systems	4	0 0		4	4
	VLSI5132	Digital Communication					
		Technology					
		Total Theory				20	20
	B. Practi	ical					
6	VLSI5111	VLSI Frontend Design & CAD Tools	0	0	3	3	2
7	VLSI5112	VLSI Backend Design & Technology CAD Tools	0	0	3	3	2
		Total Practical			•	6	4
	C. Sessio	onal				·	
8	VLSI5121	Seminar	0	2	0	2	1
		Total Sessional				2	1
		Total of Semester				28	25

Second Semester

	A. Theo	ry					
Sl.	Course	Course Name	Cor	ntact]	Hours	s/Week	Credit
No.	Code		L	Τ	P	Total	Points
1	VLSI5201	VLSI Processor Architecture	4	0	0	4	4
2	VLSI5202	VLSI Design, Verification and Testing	4	0	0	4	4
3	VLSI5203	Analog IC Design 4 0 0		4	4		
4		Elective – II					
	VLSI5231 VLSI5232	Advanced Micro & Nano Devices DSP Algorithms for VLSI System Design	4	0	0	4	4
5		Elective - III					
	VLSI5241	Low Power VLSI Circuit and System	4	0	0	4	4
	VLSI5242	Sensors					
			-	1	1	1	1
		Total Theory				20	20
	B. Prac		-		1	1	
6	VLSI5213	Analog VLSI Design Laboratory	0	0	3	3	2
		Total of practical				3	2
	C. Sessi	onal					
7	VLSI5221	Term paper leading to thesis	0	4	0	4	3
		Total Sessional				4	3
		Total of Semester				27	25

Third Semester

A.T	heory							
Sl	Course	Course Name	Cor	Contact Hours/Week				
No	Code		L	Т	Р	Total	Points	
1	HMTS6101	Research Methodology and Project Management	4	0	0	4	4	
2	VLSI6101	RF IC Design and MEMS Technology	4	0	0	4	4	
B. F	Practical							
2	VLSI6111	Digital VLSI Design Laboratory	0	0	0	6	4	
		Total				14	12	
C: 5	Sessionals							
3	VLSI6121 Thesis (Progress) and Seminar/ Presentation		0	0	0	12	4 + 4	
		Total of Semester				26	20	

Fourth Semester

	A. Sessional								
Sl.	Course	Course Name	Contact Hours/Week Credit						
No.	Code		L	Т	Р	Total	Points		
1	VLSI6221	Thesis (Final)	0	0	0	18	12		
2	VLSI6222	Thesis Viva Voce					4		
3	VLSI6223	Grand Viva					4		
		Total of Semester				18	20		

1st Year 1st Semester:

Course Name: ADVANCED MATHEMATICS							
Course Code : MATH 5103							
Contact Hours	Contact HoursLTPTotalCredit Points						
per week 4 0 0 4 4							

Module I: Probability and Stochastic Process [10L]:

Recapitulation of basic Probability concepts - Bayes theorem, Random variables, probability mass function and probability density function, Specific distributions: Binomial, Poisson, Normal.

Definition of Discrete Time Markov Chain. Examples Including Random Walk, Ehrenfest Chain and Birth-Death Chain, Transition Matrix, Chapman-Kolmogorov Equation and its application.

Module II: Graph Theory [10L]:

Tree, Binary Tree, Spanning Tree, Steiner Tree, Greedy, Divide and Conquer, Walk, Path, Cycle, Hamiltonean Graph, The Travelling Salesman Problem, Euler Graph, The Chinese Postman Problem, Planar Graph, Euler's Formula for Planar Graph and Related Problems, Matchings and Augmenting Paths, Hall's Marriage Theorem and Related Problems, Vertex Colouring, Chromatic Polynomial.

Module III: Linear Algebra [10L]:

Definition of Field, Vector Spaces, Subspaces, Linear Dependence, Basis and Dimension, Inner Product Space, Gram-Schmidt Orthogonalization Process, Linear Transformations, Kernels and Images, Matrix Representation of Linear Transformations, Change of Basis, Eigen Values and Eigen Vectors

Module IV: Optimization [10L]:

Classification of Optimization Problems, Single Variable Optimization, Multivariate Optimization Without Constraints : Semidefinite Case, Saddle Point, Multivariate Optimization with Equality Constraints: Method of Constrained Variation and Lagrange Multipliers, Solution of LPP using Simplex Method.

References:

- 1. Stochastic Processes : J. Medhi (New Age International)
- 2. Graph Theory with Applications to Engineering and Computer Science : N. Deo (PHI Learning Pvt. Ltd.)
- 3. Linear Algebra : Kenneth M. Hoffman, Ray Kunze (Prentice-Hall)
- 4. Engineering Optimization : Singiresu S. Rao (New Age International Publishers)
- 5. Introduction to Stochastic Processes : Paul G. Hoel, Sidney C. Port, Charles J. Stone (Universal Book Stall)
- 6. Stochastic Processes : Sheldon M. Ross (Wiley Series in Probability and Mathematical Statistics)

- 7. A First Look at Graph Theory : John Clark and Derek Allan Holton (Allied Publishers Ltd.)
- 8. Linear Algebra : Seymour Lipschutz, Marc Lipson (SCHAUM'S Outlines, Mc Graw Hill)
- 9. Matrices and Linear Transformations : Charles G. Cullen (Dover)
- 10. Introductory Operations Research : H.S.Kasana, K.D.Kumar (Springer-Verlag)

Course Name: VLSI DEVICE & MODELLING							
Course Code : VLSI5101							
Contact Hours	Contact HoursLTPTotalCredit Points						
per week	per week 4 0 0 4 4						

Module I: Semiconductor Physics, p-n junction and BJT [8L]

Semiconductors, Conduction, Contact Potentials, P-N Junction, Modifying the simple diode theory for describing bipolar transistor, Effect of emitter and base series resistances, Effect of base-collector voltage on collector current, Bipolar device models for Circuit and Time-dependent analyses.

Module II: MOS Capacitors and MOSFETs [12L]

Band diagrams for accumulation, depletion and inversion, threshold voltage, weak, moderate and strong inversions, Pao-Sah drain-current model, Source of MOS Capacitance, Transient Response, Capacitance-Voltage curves.

Module III: Scaled MOS Transistors [12L]

Concept of scaling (field, voltage and generalized scaling), ITRS specifications, twodimensional field patterns and Poisson's equation, charge sharing and barrier lowering, carrier mobility degradation, channel length modulation, velocity saturation, hot carrier effects (gate leakage, impact ionization)

Module IV: Compact Models [8L]

Definitions and types of compact models: physical, empirical and look-up table based models, threshold voltage-based, surface potential-based and charge-based compact models, Commercial compact models.

Text Book:

1. Fundamentals of Modern VLSI Devices by Yuan Taur & Tak H. Ning (Cambridge)

Reference Book:

- 2. The MOS Transistor (second edition) Yannis Ts ividi s (Oxford)
- 3. Compact MOSFET Models for VLSI Design by A.B. Bhattacharyya, John Wiley & Sons Pte. Ltd., IEEE Press, 2009.

Course Name: DIGITAL IC DESIGN								
Course Code : VLSI5102								
Contact Hours	L	Т	Р	Total	Credit Points			
per week	per week 4 0 0 4 4							

Module I: VLSI Circuits & Physical Layout: [12L]

Unit1: MOS Transistor Characteristics, MOS as Digital Switch, NMOS Logic Family, CMOS Logic Family, CMOS Inverter Characteristics (VTC), Inverter Delay & Noise, NAND and NOR gates, Complex Logic Circuits, Logical Effort, Pass Transistor Logic & Transmission Gate, CMOS Sequential Circuits, CMOS D-Latch and D-Flip-Flop, Pseudo NMOS Logic, Dynamic gate, Domino and NORA Logic

Unit2: CMOS Cross Section, Layout and Mask layers, Inverter Layout, Lambda Rule vs Micron Rule, Std Cell Layout Topology, Stick Diagram, Euler Path Algorithm, Layout Legging.

Module II: VLSI Design Methodology: [8L]

Unit1: Moore's Law, Scale of Integration (SSI, MSI, LSI, VLSI, ULSI, GSI), Technology growth and process Node,

Unit2: Full Custom Design, Std Cell based Semi Custom Design, Gate Array Design, PLD, FPGA: CLB, LUT, MUX, VLSI Design Cycle, Y-Chart.

Module III: EDA Tools: High level Synthesis and HDL: [8L]

Unit1: High level Synthesis EDA Flow, Control and Data Flow Graph, Scheduling, Allocation, Binding, RTL

Unit2: Why HDL ? Frontend Design Flow using HDL (Behavioral, RTL and Gate Level), VHDL/Verilog Modeling: Behavioral, Data-Flow, Structural and Mixed, FSM Example: Mealy Machine and Moore Machine.

Module IV: EDA Tools: Logical Synthesis and Physical Design Automation: [12L] Unit1: Combinational Logic Optimization: BDD: Binary Decision Diagram, OBDD, ROBDD, Technology Mapping: Pattern DAG, Subject DAG, Sequential Logic Optimization

Unit2: Physical Layout Automation EDA Flow, Partitioning: KL Algorithm, Floor-planning cost function, Placement, Detailed Routing: Channel Routing, Horizontal Constraint Graph, Vertical Constraint Graph, Cyclic Constraint, Left-edge Algorithm, Global Routing: Steiner Tree, Maze Routing.

Text Book:

- 1. Principles of CMOS VLSI Design, A Systems Perspective, Author: Neil Weste, Kamran Eshraghian, Addison Wesley, 2nd Edition, 2000
- 2. Algorithms for VLSI Physical Design Automation, Author: N. Sherwani, KLUWER ACADEMIC PUBLISHERS (3rd edition)

- 3. CMOS Digital Integrated Circuits, Analysis and Design, Author: Sung-Mo Kang, Yusuf Leblebici, Tata McGraw Hill (3rd Edition), 2006
- 4. CMOS VLSI Design, A Circuits and Systems Perspective (3rd Edition) Author: Neil Weste, David Harris, Ayan Banerjee. Pearson, 2011
- 5. Digital Integrated Circuit, Design Perspective, Author: .M. Rabaey, Prentice-Hall
- 6. VLSI Design and EDA TOOLS, Author: Angsuman Sarkar, Swapnadip De, Chandan Kumar Sarkar, SCITECH PUBLICATIONS (India) Pvt. Ltd., 2011
- 7. Algorithms for VLSI Design Automation, Author: Gerez, Wiley, 2011
- 8. A VHDL Primer, J. Bhasker, Prentice-Hall, 2013

Course Name: MICROELECTRONICS TECHNOLOGY AND IC FABRICATION								
Course Code : VLSI5103								
Contact Hours	L	Т	Р	Total	Credit Points			
per week	4	0	0	4	4			

Module I: Clean Room Technology and Oxidation [12L]

Unit1: Clean room concept- growth of single crystal from melt, surface contamination, cleaning and etching by solvent method and RCA clean.

Unit2: Growth mechanism and kinetics of oxidation, oxidation techniques and systems, oxide properties, oxide induced defects, characterization of oxide films use of thermal oxide and CVD oxide, growth and properties of dry and wet oxides, dopant redistribution, oxide quality. Etching Technology, Different kind of Interconnects, Concept of VIA.

Module II: Diffusion and ion implantation [10L]

Unit1: Diffusion: Fick's equation, atomic diffusion mechanisms, measurement techniques, diffusion in polysilicon and silicon dioxide diffusion systems.

Unit2: Ion Implantation: Range theory, equipments, annealing, shallow junction, high energy implantation.

Module III: Lithography, Deposition and Metallization [12L]:

Unit1: Lithography: Optical lithography, some advanced lithographic techniques

Unit2: Physical vapor deposition: APCVD, Plasma CVD, MOCVD

Unit3: Metallization: different types of metallization, uses and desired properties

Module IV: Process Integration [6L]:

MOSFET technology and MESFET Technology, IC manufacturing, future trends and challenges, SOI fabrication,

Text Book:

- 1. Semiconductor Devices Physics and Technology, Author: Sze, S.M.; Notes: Wiley, 1985
- 2. VLSI Technology 2ND Edition, Author: Sze, S.M.; MCGRAW HILL COMPANIES

- 3. An Introduction to Semiconductor Microtechnology, Author: Morgan, D.V., and Board, K
- 4. The National Technology Roadmap for Semiconductors , Notes: Semiconductors Industry Association, SIA, 1994
- 5, Electrical and Electronic Engineering Series VLSI Technology, Author: Sze, S.M. Notes: Mcgraw-Hill International Editions

Course Name: EMBEDDED SYSTEMS							
Course Code : VLSI5131							
Contact Hours	L	Т	Р	Total	Credit Points		
per week	per week 4 0 0 4 4						

Module I : Introduction to embedded systems: [8L]

Embedded systems overview with various type of examples in different domains such as in communication systems, robotics application and in control application, Design challenge – optimizing design metrics, embedded processor technology, Difference between embedded computer systems and general purpose computer Systems, Design methodology.

Module II: Embedded system processor design: [12L]

Custom single-purpose processors design: using finite state machine model and RTL model. Standard single-purpose processors design: Timers, and watchdog timers, LCD controller. Interfacing of Embedded Processors: Hardware protocol basics, interfacing with a generalpurpose processor, RS232, I2C, CAN protocol.

Module III: [10L]

Introduction to 8051 microcontroller: 8051 architecture, pin configuration, I/O ports and Memory organization. Instruction set and basic assembly language programming. Interrupts, Timer/Counter and Serial Communication in 8051, Introduction to PIC & ARM micro-controllers.

Module IV: [10L]

Interfacing with Memory & I/O Devices:

Different types of embedded memory devices and interfacing: SRAM, DRAM, EEPROM, FLASH, CACHE memory. Different types of I/O devices and interfacing: Keypad, LCD, VGA. Square wave and pulse wave generation, LED, A/D converter and D/A Converter interfacing to 8051.

Text Book:

1. Embedded System Design: A Unified Hardware/Software Approach -2^{nd} Ed Frank Vahid and Tony Givargis

Reference Book:

2. Computers as Components: Principles of Embedded Computing System Design -2^{nd} Ed Wayne Wolf.

Course Name: DIGITAL COMMUNICATION TECHNOLOGY								
Course Code : VLSI5132								
Contact Hours	Contact HoursLTPTotalCredit Points							
per week	per week 4 0 0 4 4							

Module I: [10L]

Review of baseband digital signal transmission –PCM DM ADM ADPCM. Inter Symbol Interference (ISI), Nyquist criteria for no ISI in band limited channel, Eye Diagram & interpretation, Error Vector Magnitude, Error coding techniques, Viterbi decoding.

Parametric decoding: Sub band coding APC LPC voice excited vocoder

Synchronization – Symbol and Frame synchronization

Equalizer: Linear equalization Decision feedback equalizer iterative equalizer and decoding

Module II: [10L]

Digital Modulation:

Review of modulation schemes – BPSK DPSK QPSK M-ary PSK QASK MSK BFSK M-ary FSK - principles transmitters receivers signal space presentation bandwidth efficiency

GMSK Orthogonal frequency division multiplexing (\mbox{OFDM}) – principle generation and detection

Bit error performance of bandpass signal – Narrow band noise model Error performance of different shift keying techniques like BPSK, Comparison of bandwidth efficiency and error performance of modulation schemes

Module III: [9L]

Multiplexing and multiple access: TDM/TDMA FDM/FDMA Space DMA ALOHA – slotted ALOHA and reservation ALOHA CSMA-CD CSMA- CA basic techniques and comparative performances

Spread spectrum modulation: Principle of DSS, processing gain jamming margin single tone interference probability of error

Principle of frequency hopped spread spectrum (FHSS) – slow frequency and fast frequency hopping

Principle of CDMA Multiple access interference (MAI) and limit of simultaneous users Digital cellular CDMA system – forward and reverse link error rate performance

Module IV: [9L]

Optimum Detection and Estimation:

Noise vector in signal space Bayes detection of received signal, optimum M-ary receiver design

Decision region and minimum error probability

Matched filter, Optimum detection of 16 QAM signal, MPSK signal orthogonal and bi orthogonal signal

Decision criterion: maximum likelihood Neyman Pearson and Minimax decision criterion Estimation: Linear estimation – simple mean Linear mean squared error Wiener filter Non linear estimation: Bayes estimation MAP ML estimates

Text Book:

1. Digital Communications 4th edition J G Proakis MGH international Edition

2. Principle of Communication Systems Taub and Schilling 7th edition TMH

3. Digital Communications :Fundamentals and Applications 2nd edn 2008 Bernard Sklar and Pabitra Kumar Ray Pearson Education

4. Principle of Digital Communications Simon Haykin Wiley Student Edition

5. Digital Communications Zeimer and Tranter CRC Press

6. Wireless Communication & Networks: 3G & Beyond Iti Saha Mishra, McGraw-Hill Education, 2^{nd} Edition

Course Name: VLSI Frontend Design & CAD Tools							
Course Code : VLSI 5111							
Contact Hours	Contact Hours L T P Total Credit Points						
per week 0 0 0 3 3 2							

List of Experiments:

- 1. Introduction to XILINX-ISE Simulator, VHDL Coding and Test Bench Simulation
 - a. Logic Design and Verification of a 15 bit Ripple-Carry Adder
 - b. Logic Design and Verification of a universal shift register
 - c. Logic Design and Verification of a Finite State Moore Machine
 - d. Logic Design and Verification of a Finite State Mealy Machine
 - e. Design of hand shake protocol to establish Communication between Master and Slave
- 2. **FPGA Programming Flow** using XILINX Kits: Implementing and verifying many of above experiments in FPGA hardware Kits.

Course Name: VLSI Backend Design & Technology CAD Tools							
Course Code : VLSI 5112							
Contact Hours	Contact HoursLTPTotalCredit Points						
per week	per week 0 0 3 3 2						

List of Experiments:

Sub Micron and Deep Sub Micron Technology based Experiments:

- 1) Introduction to Tanner Design & Layout Tools and SPICE Analysis
 - a. Transient analysis of CMOS Inverter Circuit
 - b. DC & Parametric analysis of CMOS Inverter
 - c. Layout Design and Verification Using Tanner Tools
- 2) Introduction to Cadence Virtuoso & Assura Tools
 - a. Transient, DC, Parametric analysis of CMOS Inverter
 - b. Implementation of Various Logic gates using Advanced CMOS technology
 - c. Layout design and Verification Using Cadence: Std Cell Layout
 - d. Parasitic Extraction, Back-annotation and Post Layout Timing Analysis Using Cadence
- 3) Introduction to TCAD Synopsys Device and Process Simulator: Nano Technology

1st Year 2nd Semester:

Course Name: VLSI PROCESSOR ARCHITECTURE						
Course Code : VLSI5201						
Contact Hours	L	Т	Р	Total	Credit Points	
per week	4	0	0	4	4	

Module I: Fundamentals: [8L]

Architecture organization, basic structure of instruction set architecture (ISA arch) and Flynn's taxonomy. Comparison of Von-Neumann and Harvard architecture, Microcoded and hardwired control architecture, scalar and Vector processors architecture, CISC and RISC architecture. Basic of pipelining, pipeline hazards and solutions.

Module II: The DSP and Its Impact on Technology: [12L]

Parallel computation using superscalar architecture, description of the very long Instruction word architecture (VLIW arch), detail description of TI TMS320C5x DSP processor architecture.

Module III: Accelerator :[10L]

Need for accelerators, Accelerators and different types of parallelism, Processor architectures and different approaches to acceleration. General-Purpose Embedded Processor Cores: The ARM.

Module IV: Multiprocessor and multithreaded processor [10L]

Utilization of course-grain parallelism, chip-multiprocessors, multithreaded processors, SMT processor, A benefits analysis of processor customization, Using microprocessor cores in SOC design, Benefiting from microprocessor extensibility, how microprocessor use differs between SOC and board-level design

Text Book:

1. Computer Architecture: Pipelined and Parallel Processor Design – 2nd Ed Michael J. Flynn

Reference Book:

2. Digital Signal Processors: Architecture, Programming and Applications - B. Venkataramani, M. Bhaskar

3. ARM System-on-Chip Architecture -2^{nd} Ed Steve Furber

4. Computer System Design: System-on-Chip – 1st. Ed Michael J. Flyn, Wayne Luk

Course Name: VLSI DESIGN VERIFICATION AND TESTING						
Course Code : VLSI5202						
Contact Hours	L	Т	Р	Total	Credit Points	
per week	4	0	0	4	4	

Module I: VLSI Memory Design: [12L]

Types of Memory, Memory Organization, Memory Folding Criteria, Memory Cell Design Method for Write and Read Operation, Critical Path Analysis & Memory Access Time, DRAM 4T, 3T, 1T Cell Design Method, SRAM 8T, 6T Cell Design Method, Sense Amplifier Operation, Multiport Register File Design Challenges, Mask ROM, ROM Programming Techniques, Flash ROM

Module II: VLSI Interconnect Design: [6L]

Component of Interconnect, Interconnect Cross Section, Wire material, Interconnect Modelling, Interconnect Design Issues and WirePlan: Capacitance, Delay, Lumped Model vs Distributed Model, RC Scaling, Repeater, Interconnect Power, Interconnect Noise: Coupling, Cross Talk

Module III: VLSI Verification Flows and Static Timing Analysis: [12L]

Unit1: Logic Verification, Circuit Verification, Layout Verification (DRC, LVS), pre-layout simulation, parasitic Extraction and Back-annotation, post layout verification,

Unit2: Timing checks (set-up, hold), process variation study with PVT analysis, Library Cell characterization, Static Timing Analysis: Types of Path for Timing Analysis, Launch path, Capture Path, Longest Path, Shortest Path, Critical Path, Clock Skew

Module IV: Si-Testing: [10L]

Why Testing, Challenge of Si-Testing, Manufacturing Defects, Die (Inter and Intra) Variation, Yield, DPM, Combinational Circuit Testing: Logical Fault Modelling: Stuck at Faults (D-Algorithm), Bridging Fault, Transistor Stuck open/Stuck Short, ATPG, Path Delay Fault, Sequential Circuit Testing: DFT, Scan Design, SFF, LSSD-SSF, BIST

Text Book:

- 1. Principles of CMOS VLSI Design, A Systems Perspective, Author: Neil Weste, Kamran Eshraghian, Addison Wesley, 2nd Edition, 2000
- VLSI Test Principles and Architectures, Design for Testability, Author: Laung-Terng Wang, Cheng-Wen Wu, Xiaoqing Wen, The Morgan Kaufmann series in Systems on Silicon. 2006 Elsevier

Reference Book:

- 3. CMOS VLSI Design, A Circuits and Systems Perspective (3rd Edition) Author: Neil Weste, David Harris, Ayan Banerjee. Pearson, 2011
- 4. Digital Integrated Circuit, Design Perspective, Author: .M. Rabaey, Prentice-Hall

Course Name: ANALOG IC DESIGN							
Course Code : VLSI5203							
Contact Hours	L	Т	Р	Total	Credit Points		
per week	4	0	0	4	4		

Module I: CMOS OPAMP Circuits: [12L]

Unit1: CMOS models for analog circuits - Small signal equivalent circuit, temperature effect and sensitivity, overview of electrical noise. Analog sub-circuits : CMOS switch, resistors, current source, sink, current mirror, voltage and current references.

Unit2: CMOS Amplifiers & CMOS Operation Amplifiers : Basic concepts , Performance Parameters , Single Stage OPAMP, Two stage OPAMP, Stability and Phase compensation, Cascode OPAMP

Unit3: Comparators: Characterisation, Two stage open loop comparators, Discrete time comparators, high speed comparator circuits, CMOS S/H circuits

Module II: RF Analog Circuits & Sub-circuits: [8L]

Capacitors and Inductor s in VLSI circuits, Bandwidth estimation techniques, Design of high frequency amplifiers, Design of low noise amplifiers, Design of Mixers of RF power amplifiers, Architectures of RF receivers and transmitters.

Module III: Data Converter Fundamentals & Architecture: [10L]

Ideal D/A converters, Ideal A/D converter, Serial and Flash D/A converters and A/D converters, Medium and High Speed converters, Over-sampling converters, performance limitations, Design considerations.

Module IV: Special Circuits: [10L]

Unit1: Switched Capacitor circuits: General considerations, Resistor simulation using different Switched Capacitor topologies, Switched Capacitor integrators, First and second order switched capacitor filter circuits.

Unit2: CMOS voltage controlled oscillators, Phase locked loops, Ring oscillators.

Text Book:

1. CMOS Analog Circuit Design (second edition) Phillip E. Allen and Douglas R. Holberg (Oxford)

Reference Book:

2. The MOS Transistor (second edition) Yannis Tsividi s (Oxford)

Course Name: ADVANCED MICRO AND NANO DEVICES						
Course Code : VLSI5231						
Contact Hours		Т	Р	Total	Credit Points	
per week	4	0	0	4	4	

Module I: Leakage Current Mechanisms and Reduction (6+6=12L)

Unit 1: Sub-threshold leakage, band-to-band leakage, gate-oxide tunneling, gate-induced-drain leakage etc.

Unit 2: High-K gate dielectric and Metal-gate technology: Concept of EOT, leakage current control, use of various high-K oxides, work function engineering, Fermi-level pinning.

Module II: SOI MOSFETs [6L]

Partially-depleted SOI, Fully-depleted SOI, Advantages and disadvantages of SOI structure.

Module III: Multigate Structures [12L]

DG-MOSFETs, TRI Gate MOSFETs, FinFETs, Surround gate MOSFETs, Omega Gate MOSFETs, Volume inversion, Random Dopant Fluctuation, Concept of undoped body, Underlap device structure, Symmetry and asymmetry MOSFET structure.

Module IV: Hetero Structures and Quantum Well devices [10L]

Quantization and low-dimensional electron gas, band alignment in Si/SiGe hetero-structures, HEMTs, Carbon Nano-tube, Graphene device.

Text Book:

1. The MOS Transistor (second edition) Yannis Tsividis (Oxford)

- 2. Fundamentals of Modern VLSI Devices by Yuan Taur & Tak H. Ning (Cambridge)
- 3. FinFETs and Other Multi-Gate Transistors by J.P. Colinge, Springer, 2008.

Course Name : DSP ALGORITHMS FOR VLSI SYSTEM DESIGN							
Course Code : VLSI5232							
Contact Hours	L	Т	Р	Total	Credit Points		
per week	4	0	0	4	4		

Module I: DSP Algorithms: [14L]

Typical DSP Algorithms, Adaptive Filters, Discrete Cosine Transform, Vector Quantization, Viterbi Algorithm, Decimator & Expander, Wavelet Transform, Filter Banks.

Module II: Iteration Bound: [8L]

Signal-flow graph, Data-flow graph, Dependence graph, Critical path, Loop & Iteration bounds, Computation of iteration bound .

Module III: Pipelining and Retiming Techniques: [8L]

Fine-grain pipelining of FIR filter, Low power aspects for pipelining and parallel processing, Cutset retiming, Clock period and Register minimizations.

Module IV: Unfolding Algorithms: [10L]

SISO and MIMO systems, properties of unfolding, sample period reduction, word and bit level parallel processing.

Text Book:

1. VLSI Digital Signal Processing Systems: Design and implementation Keshab K Parhi, Wiley India, 2008

Reference Book:

- DSP Processor Fundamentals: Architectures and Features, Phil Lapsley, Jeff Bier, Amit Shoham, Edward Lee, Wiley – IEEE Press, Jan, 1997
- 3. Computer Architecture A Quantitative Approach, John L Hennessy, David A. Patterson,, Elsevier, 2012.

Course Name: LOW POWER VLSI CIRCUIT AND SYSTEM							
Course Code : VLSI5241							
Contact Hours	L	Т	Р	Total	Credit Points		
per week	4	0	0	4	4		

Module I: Dynamic Power Reduction: [12L]

Unit1: Introduction: Why Low Power ? Definition of dynamic power, Transition probability, Signal probability, Transition probability of basic gates, Glitch power, source of switching capacitance

Unit2: Dynamic Power reduction with Vdd, Delay vs Power Trade-off, Dual Vdd, Dynamic Voltage Scaling (DVS), Dynamic Power Management, Capacitance Scaling, Transistor sizing, Transition probability reduction by clock gating, Logic restructuring, Input Reordering, Glitch reduction

Module II: Standby Power Reduction: [12L]

Unit1: Leakage power definition, Gate Leakage, Channel Leakage, Junction Leakage. Channel leakage issue with Threshold Scaling, Leakage vs Dynamic power

Unit2: Technology Solution of Gate Leakage reduction: High-K, FinFET, Channel leakage reduction techniques: Multiple Threshold Voltage, Long Channel Transistor, Device Downsizing, Stacking, Power Gating, Dual Vdd, Dynamic Body-Biasing, Technology Solution: FinFET

Module III: Short Circuit Power Reduction: [6L]

Definition, Dependency on Load Capacitance, Various reduction techniques

Module IV: Power Reduction at Various Design Phase: [10L]

System level, Algorithm level, Architecture Level (Parallel vs Pipeline), Gate level, transistor level, Power Analysis Tool, Low Power Memory Circuit Example on DRAM, SRAM, ROM, Power issue with Dynamic Gates: Floating node and Keeper Solution.

Text Book:

1. Practical Low Power Digital VLSI Design, Author: Gary Yeap, KLUWER ACADEMIC PUBLISHERS, 2010

Reference Book:

2. Low Power CMOS VLSI Circuit Design, Author: Kuashik Roy and Sharat Prasad, John Wiley & Sons, Inc. 2009

Course Name: SENSORS							
Course Code : VLSI 5242							
Contact Hours	L	Т	Р	Total	Credit Points		
per week	4	0	0	4	4		

Module I: [10L]

Principles of Physical and Chemical Sensors: Sensor classification, Sensing mechanism of Mechanical, Electrical, Thermal, Magnetic, Optical, Chemical and Biological Sensors. Sensor Characterization and Calibration: Study of Static and Dynamic Characteristics, Sensor reliability, aging test, failure mechanisms and their evaluation and stability study.

Module II [10L]

Sensor Modeling: Numerical modeling techniques, Model equations, Different effects on modeling (Mechanical, Electrical, Thermal, Magnetic, Optical, Chemical and Biological) and examples of modeling. Sensor Design and Packaging: Partitioning, Layout, technology constraints, scaling.

Module III [10L]

Sensor Technology: Thick and thin films fabrication process, Micro machining, IOC (Integrated Optical circuit) fabrication process, Ceramic material fabrication process, Wire bonding, and Packaging. Sensor Interfaces: Signal processing, Multi sensor signal processing, Smart Sensors, Interface Systems. Sensor Applications: Process Engineering, Medical Diagnostic and Patient monitoring,

Module IV [10L]

MEMS: Introduction, Scaling, MEMS Markets and Applications MEMS materials and fabrication methods, with emphasis on silicon micromachining, Process simulation: basic lithography, deposition, and etching processes for MEMS.

Text Book:

1. AN INTRODUCTION TO MICROELECTROMECHANICAL SYSTEMS ENGG. BY NADIM MALUF & K WILLIAMS, ARTECH HOUSE

Reference Book:

2. RF MEMS THEORY DESIGN AND TECHNOLOGY BY G.M.REBEIZ, WILEY

Course Name: Analog VLSI Design Laboratory							
Course Code : VLSI 5213							
Contact Hours	L	Т	Р	Total	Credit Points		
per week	0	0	3	3	2		

List of Experiments:

Sub Micron and Deep Sub Micron Technology based Experiments:

- 1) Cadence Virtuoso and Assura Tool Based Analog Experiments
 - a. MOS as Resistors, Current Source, Sink, Current Mirror
 - b. DC, Transient and AC analysis of Single Stage Amplifier
 - c. Layout Design and Verification of Single Stage Amplifier
 - d. Circuit and Layout design of Differential Amplifier
 - e. Circuit and Layout design of Operational Amplifier
 - f. ADC/DAC Design
- 2) Introduction to Texas Instruments Analog System Laboratory Starter Kits (ASLK)

Course Name : Research Methodology and Project Management						
Course Code	: HMTS6101					
Contact	L	Т	Р	Total	Credit	
Hours		Points				
per week	4	0	0	4	4	

Course outcome:

1.Idea about research methodology

2. Project – implementation and appraisal

3.Project planning

Module 1

Meaning of Research, Types of Research, process of Research, Formulation of Research Problem and Development of Research Hypotheses, Data Collection — Primary and Secondary Data, Types of Measurement Scale, Sample Designing, Sampling vs. Non sampling Error, Different types of Sample designing, Determination of Sample Size.

Testing of Hypotheses, Null and Alternate hypothesis, One tailed and two-tailed test, Type I and Type II error, Steps in Testing Hypothesis, Level of Significance and Critical region, Z test, t Test, P Test, ANOVA, Correlation and Regression Analysis, Chi-Square test.

Module 2

Concepts of a Project, Characteristics of a Project, Project Life Cycle Phases, Difference between Project Management and Functional Management, Roles and Responsibilities of a Project Manager, Matrix organization of a Project.

Module 3

Project Appraisal: DPR — Technical, Marketing, Environment, Social, Financial Appraisal [Non Discounted Cash Flow Technique like Payback and Accounting Rate of return (ARR); Discounted Cash Flow technique like Profitability Index (P/I) or Benefit Cost ratio (BCR), Net Present Value (NPV), Internal Rate of return (IRR)]

Module 4

Project Planning, Work Breakdown Structure (WBS), Networking Concepts, Network Analysis, Difference between PERT and CPM, Calculation of Floats, Concept of Crashing, Gantt Chart, LOB.

Case Study on Project Management

Recommended Books: Research Methodology Concepts and Cases by Chawla & Sondhi, Vikas Publishing House.

Project Management by S Choudhury, TMH

Projects: Planning, Analysis, Selection, Implementation & Review by Prasanna Chandra, TIvII-I.

Course Name: RF IC Design and MEMS Technology							
Course Code : VLSI6101							
Contact	L	Т	Р	Total	Credit		
Hours					Points		
per week	4	0	0	4	4		

Course outcome:

1.Design of RF system blocks in VLSI 2.MEMS – technology and fabrication 3.MEMS for RF applications

Module I: [10L]

Prerequisite:

RFIC design tradeoffs; Fading, Diversity; Multiple Access Schemes; S and ABCD parameters; Resonance in LC circuit; Concept of transmission lines-Reflection Coefficient; Impedance transformation and matching;

Unit1: RF Devices:

Design of RF passive devices- capacitor, inductors; Design of RF MOS devices; Spectre RF ,BJT, MOS spice modeling in RF.

Unit2: RF Systems basics:

Nonlinearity in RF Systems; IIP3, SFDR; Classical two port network theory of Noise; Noise in MOSFETs; Testing of RF System – Noise, Distortion Measures and Mitigation Methods;

Module II: [12L]

Unit1: RF System Blocks:

Wideband amplifier design; LNA Design; Mixer Design, Gilbert mixer; Linearization techniques; Design Overview of oscillator and Mixer, Frequency Synthesizer; VCO design; power amplifier design – A,B,AB,C,D,E,F;

Unit2: Transmitter Architecture- PLL/CDR Loop, Frequency Divider

Unit2: Receiver architectures- direct conversion, heterodyne, image reject architectures; **Unit3: Applications-** GSM,CDMA architectures.

Module III: [9L]

Unit1: Introduction to MEMS technology:

Basics of MEMS; Areas of application; Silicon as Design material; Important Material Properties and Physical Effects; Other design materials (GaAs, Quartz, SiC, Polymer etc.,) **Unit2: MEMS Fabrication:**

Bulk micromachining; Surface micromachining; Different types of etchants and etching methods; Nonlithographic Microfabrication Technologies;

Module IV: [9L]

Unit1: MEMS Structures and Systems for sensors and actuators:

Sensing and Actuation methods; Sensors of different types with example of each type (Mechanical, temperature, chemical, Lab on Chip, microfluidic, bio-sensors);micro pump; 3D Accelerometer, Digital Light Projector;

Unit2: MEMS structure and systems for RF applications:

Passive Electrical Components: Capacitors and Inductors; Surface-Micromachined Variable Capacitors;Bulk-Micromachined Variable Capacitors ;Micromachined Inductors; Microelectromechanical Resonators; Microelectromechanical Switches;

Text Books:

- 1. The Design of CMOS Radio-Frequency Integrated Circuits -Thomas H. Lee, Cambridge University Press; 2 edition
- 2. MEMS- NPMahalik, Mc Graw Hills Publishers.

Referense books:

- 1. An introduction to microelectromechanical systems –Nadim Maluf, Kirt Williams, Artech House 2nd Edition
- 2. Mems & Microsystems: Design & Manufacture-Tai-Ran Hsu, Mc Graw Hills Publishers, 1st Edition
- 3. RF Microelectronics- Behazad Razavi, Pearson Education, 2nd Edition
- 4. VLSI for Wireless Communication- Bosco Leung, Springer, 2nd Edition
- 5. Microsystem Design, Senturia, Kluwer Academic Publishers.
- 6. Fundamentals of Micro Fabrication, Madou, CRC Press.

Course Name: Digital VLSI Design Laboratory							
Course Code : VLSI6111							
Contact	L	Т	Р	Total	Credit		
Hours					Points		
per week	0	0	0	6	4		

List of Experiments:

Sub Micron and Deep Sub Micron Technology based Experiments:

- 1) Combinational Circuit Example (Cadence Virtuoso and Assura Tools)
 - a. Circuit Design,
 - b. Critical Path Timing Analysis,
 - c. Layout Design and Verification,
 - d. Parasitic Extraction, Back-annotation and Post Layout Timing Analysis
- 2) Sequential Circuit Example (Cadence Virtuoso and Assura Tools)
 - a. Circuit Design,
 - b. Setup and Hold Analysis,
 - c. Layout Design and Verification,
 - d. Parasitic Extraction, Back-annotation and Post Layout Timing Analysis

- 3) Cadence Semi Custom Design Flow
 - a. Incisive Logic Simulation: Verilog Coding and Test Bench Verification
 - b. Encounter RTL Compiler: Logic Synthesis
 - c. Encounter Physical Design Implementation: Floor-planning, Powerplanning, Placement, CTS, Routing, Static Timing Analysis
 - d. ASIC views .lib, .lef, .gds, .sdf
 - e. Std. cells- Design, layout, characterization
 - f. Logical Equivalence checking